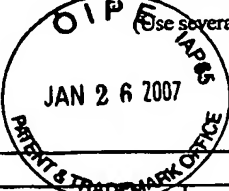


Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 119051		APPLICATION NO. 10/796,018	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Tsuyoshi YAMADA et al.		GROUP 2828	
							
				FILING DATE March 10, 2004			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
JM	1.	4,425,648	1/10/1984	HOLLY			
JM	2.	5,144,630	9/1/1992	LIN			
	3.	5,249,192	9/26/1993	KUZIENGA et al.			
JM	4.	5,331,649	7/19/1994	DACQUAY et al.			
JM	5.	5,345,457	9/6/1994	ZENZIE et al.			
JM	6.	5,528,612	6/18/1996	SCHEPS et al.			
JM	7.	US 2002/0061037 A1	5/23/2002	SCHMID et al.			
JM	8.	US 6,636,537 B2	10/21/2003	TAKADA			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
JM	9.	JP A 10-65238 w/abstract & transl.	3/6/1998	JAPAN			
JM	10.	JP A 2002-134816 w/abstract & transl.	5/10/2002	JAPAN			
JM	11.	JP A 2001-257398 w/abstract & transl.	9/21/2001	JAPAN			
JM	12.	JP A 2002-151774 w/abstract & transl.	5/24/2002	JAPAN			
JM	13.	JP A 2003-204099 w/abstract & transl.	7/18/2003	JAPAN			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
JM	14.	Clarkson et al.; "Simple method for reducing the depolarization loss resulting from thermally induced birefringence in solid-state lasers"; Optics Letters, Vol. 24, No. 12; June 15, 1999; pp 820-822					
JM	15.	Extended Abstracts (The 63 rd Autumn Meeting, 2002); The Japan Society of Applied Physics; September 24-September, 27, 2002					
JM	16.	Extended Abstracts (The 50 th Spring Meeting, 2003); The Japan Society of Applied Physics and Related Societies; March 27-March 30, 2003					
JM	17.	Extended Abstracts (The 64 th Autumn Meeting, 2003); The Japan Society of Applied Physics; August 30-September 2, 2003					
JM	18.	Reports on the 313 th Topical Meeting of the Laser Society of Japan; September 17, 2003					
JM	19.	Program (24 th Annual Meeting of Japan Society for Laser Surgery and Medicine); November 14-November 15, 2003					
JM	20.	Digest of Technical Papers; (24 th Annual Meeting of the Laser Society of Japan); January 29-January 30, 2004					
EXAMINER /James Menefee/				DATE CONSIDERED 02/20/2007			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: May 21, 2004